,								
	PETITION FOR EX	XTENSION OF TIM (Large Entity		DER 37 CFR	t 1.136(a)	F	Docket No. SEC.760	
	In Re Application Of: Seung-pil Chung et al.						SEC.760 OCT 28 2003	
	Serial No. 09/689,814	Filing Date 13 October 2000	TEAT & T	THANK MAY	Examiner		Grup Art Unit 1763,	
-	Invention: METHOD FOR REMOVING OXIDE LAYER AND SEMICONDUCTOR MANUFACTURING APPARATUS FOR REMOVING OXIDE LAYER .							
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,		TO THE CC	<u>SZIMMC</u>	SIONER FOR F	PATENTS:	_		
	This is a request under the provisions of 37 CFR 1.136(a) to extend the period for filing a response to the Office Action of 25 June 2003 above-identified application. Date							
Ī	The requested extension	_		·				
	☐ One month	☐ Two months	П	Three months			☐ Five months	
	from: 2	25 September 2003 Date		until:	25 Octob	ber 2003	3	
The fee for the extension of time is \$110 and is to be paid as follows: A check in the amount of the fee is enclosed. The Director is hereby authorized to charge any fees which may be required, or credit any overpays Deposit Account No. 50-0238 If an additional extension of time-is-required, please consider this a petition therefor and charge any additional fees which may be required to Deposit Account No. 50-0238 10/24/2003 SSITHIB1 00000113 09689814 01 FC:1251 110.00 0P								
	Dated: 23 October 2003 KENNETH D. SPRINGER							
	REG. NO.: 39,843							
	VOLENTINE FRANCOS, 12200 SUNRISE VALLEY RESTON, VA 20191 TEL. NO.: (703) 715-0870	Y DRIVE, SUITE 150			on first class mail unde	der 37 C.F.	ent and fee is being depos with the U.S. Postal Servi F.R. 1.8 and is addressed t P.O. Box 1450, Alexandria	ice as to the
	ı			,	Signature c	of Person !	Mailing Correspondence	
1	cc:			/				
- 1				J'	A Typed or Printed 7	Name of P	Person Mailing Corresponder	*****